

Notice of References Cited	Application/Control No. 10/656,158	Applicant(s)/Patent Under Reexamination PARK ET AL.	
	Examiner Hong Cho	Art Unit 2616	Page 1 of 1

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*	B	US-7,050,424	05-2006	Cheng et al.	370/352
*	C	US-2003/0158940	08-2003	Leigh, Kevin B.	709/226
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NON-PATENT DOCUMENTS

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